

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|---|------------------|---------|------------------|
| L1 | 33 | (wafer or substrate or semiconductor).clm. and (controller and memory and sputter\$3).clm. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT ; IBM_TDB | OR | ON | 2007/06/14 11:55 |